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1995

INFORMATION DISCLOSURE CITATION WITH DOCUMENT COPIES

Submitted by: <i>Linda M. Deschere</i>	Atty Docket No. UM939	Serial No. 08/224,961
Linda M. Deschere	Applicant Gerard A. Mourou, et al	
Reg. No: 34,811	Filing Date 04/08/94	Group 2501 2106

U.S. PATENT DOCUMENTS

Exam. Init.	Document Number	Date	Name	Class	Subclass	Filing Date (if approp)

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Subclass	Translation	
						Yes	No

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

<i>GSE</i>	D.H. Reitze, X. Wang, H. Ahn, and M.C. Downer, "Femtosecond Laser Melting of Graphite", Physical Review B, Vol. 40, No. 17, December 15, 1989
<i>GSE</i>	F. Müller, K. Mann, P. Simon, J.S. Bernstein, and G.J. Zaal, "A Comparative Study of Decomposition of Thin Films by Laser Induced PVD with Femtosecond and Nanosecond Laser Pulses", SPIE, Vol. 1858, 464-475, 1993

Examiner

Geoffrey S. Evans

Date Considered

May 11, 1996

*Examiner: Initial if reference considered whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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OMB No. 0651-0011(12/31/86)

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<i>GSE</i>	S. Küper and M. Stuke, "Femtosecond uv Excimer Laser Ablation", Applied Physics B, Vol. 44, 199-204, 1987
<i>GSE</i>	S. Preuss, M. Späth, Y. Zhang, and M. Stuke, "Time Resolved Dynamics of Subpicosecond Laser Ablation", Applied Physics Letters, Vol. 62, No. 23, 3049-3051, June 7, 1993
<i>GSE</i>	A.M. Malvezzi, N. Bloembergen, and C.Y. Huang, "Time-Resolved Picosecond Optical Measurements of Laser-Excited Graphite, Physical Review Letters, Vol. 57, No. 1, 146-149, July 7, 1986

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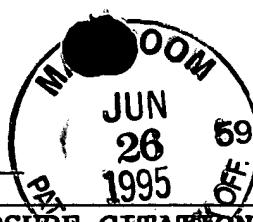
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<i>GSE</i>	C.V. Shank, R. Yen, and C. Hirlimann, "Time-Resolved Reflectivity Measures of Femtosecond-Optical-Pulse-Induced Phase Transitions in Silicon", Physical Review Letters, Vol. 50, No. 6, 454-457, February 7, 1983
<i>GSE</i>	C.V. Shank, R. Yen, and C. Hirlimann, "Femtosecond-Time-Resolved Surface Structural Dynamics of Optically Excited Silicon", Physical Review Letters, Vol. 51, No. 10, 900-902, September 5, 1983
<i>GSE</i>	C.V. Shank and M.C. Downer, "Femtosecond Dynamics of Highly Excited Semiconductors", Mat. Res. Soc. Symp. Proc., Vol. 51, 15-23, 1985

Examiner

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*Geoffrey S. Evans**May 11, 1996*

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GSE	English Abstract for DE 41 19024 A1	12/17/92	Germany	—	—	XX	
GSE	DE 41 19024 A1	12/17/92	Germany	—	—		XX

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GSE	International Search Report Form PCT/ISA/210 Dated 31 July 1995 and Mailed 04 August 1995
GSE	M.W. Berns et al., "Laser Microsurgery in Cell and Developmental Biology", Science, Vol. 213, No. 31, 505-513, July 1981
GSE	G.L. LeCarpentier et al., "Continuous Wave Laser Ablation of Tissue: Analysis of Thermal and Mechanical Events", IEEE Transactions on Biomedical Engineering, Vol. 40, No. 2, 188-200, February 1993
GSE	C. LeBlanc, "Realization and Characterization of a High Intensity Femtosecond Laser System Based on all Titanium Doped Sapphire", Annales de Physique, Vol. 19, No. 1, Abstract, February 1994

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